

10/529152

JC06 Rec'd PCT/PTO 24 MAR 2005

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q87054

Yasuki KIMURA

Appln. No.: National Stage Entry of PCT/JP2004/004938 Group Art Unit: Not Yet Assigned

Confirmation No.: Not Yet Assigned

Examiner: Not Yet Assigned

Filed: March 24, 2005

For: METHOD OF ETCHING A CHROMIUM-BASED THIN FILM AND METHOD OF
 MANUFACTURING A PHOTOMASK

PRELIMINARY AMENDMENT

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified application as follows on the
accompanying pages.

TABLE OF CONTENTS

AMENDMENTS TO THE SPECIFICATION.....	2
AMENDMENTS TO THE CLAIMS	5
REMARKS	11